

Attorney Docket: 081468-0302644
Client Reference: P-1698.000-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
FLAGELLO ET AL.

Confirmation Number: 7154

Application No.: 10/698,012

Group Art Unit: 2854

Filed: October 31, 2003

Examiner: Unassigned

Title: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD



PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to initial examination on the merits, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 14, delete paragraph [0052] and replace it with the following new paragraph:

[0052] It should be appreciated that a similar system as shown in Figures 4 and 5 is between the substrate W and the transparent plate 12. The system shown in Figures 4 and 5 is more fully described in ~~European~~ U.S. Patent Application ~~02257822.3~~ 10/705,805, filed November 12, ~~2002~~ 2003, the entire contents of which are incorporated herein by reference.